## Notice of References Cited 10/646,823 Examiner

Applicant(s)/Patent Under
Reexamination
ISHIMI, KOICHI

Art Unit
2816

Page 1 of 1

## U.S. PATENT DOCUMENTS

Hai L. Nguyen

Application/Control No.

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	Α	US-6,690,525	02-2004	Ruegg et al.	360/51
X	В	US-6,642,762	11-2003	von Kaenel, Vincent R.	327/158
X	С	US-6,639,958	10-2003	Hohler et al.	375/376
X	D	US-6,633,190	10-2003	Alvandpour et al.	327/291
X	E	US-6,493,829	12-2002	Kubo, Takashi	713/500
X	F	US-6,441,662	08-2002	Ikeda, Yutaka	327/160
X	G	US-6,424,193	07-2002	Hwang, Sung-Sik	327/158
X	Н	US-6,330,197	12-2001	Currin et al.	365/194
Х	I.	US-6,225,840	05-2001	Ishimi, Kouichi	327/116
X	J	US-6,157,226	12-2000	Ishimi, Kouichi	327/116
X	К	US-5,771,264	06-1998	Lane, Chris	375/376
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N			•		
	0					
	Ρ					·
	ø					
	R					
	S					
	۲					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U						
	٧						
	w						
	х						

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.